

**Application Data Sheet****Application Information**

Application Type:: Utility  
CD\_ROM or CD-R?: None  
Title:: SILICON LAYER PRODUCTION METHOD AND  
SOLAR CELL PRODUCTION METHOD  
Attorney Docket Number:: 03500.109446.  
Total Drawing Sheets:: 2  
Small Entity?: No

**Applicant Information**

Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: MASAKI  
Family Name:: MIZUTANI  
City of Residence:: Hikone-shi  
State or Province of Residence:: Shiga-ken  
Country of Residence:: Japan  
  
Primary Citizenship Country:: Japan  
Status:: Full Capacity  
Given Name:: SHOJI  
Family Name:: NISHIDA  
City of Residence:: Hiratsuka-shi  
State or Province of Residence:: Kanagawa-ken  
Country of Residence:: Japan  
  
Primary Citizenship Country:: Japan  
Status:: Full Capacity

Given Name:: KATSUMI  
Family Name:: NAKAGAWA  
City of Residence:: Zama-shi  
State or Province of Residence:: Kanagawa-ken  
Country of Residence:: Japan

### Correspondence Information

Correspondence Customer Number:: 5514

### Representative Information

Representative Customer Number::	05514
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### Domestic Priority Information

Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application	National stage of	PCT/JP2005/009305	05/17/2005

### Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2004-156968	05/27/2004	Yes

### Assignee Information

Assignee name:: CANON KABUSHIKI KAISHA  
Street of mailing address:: 3-30-2, Shimomaruko, Ohta-ku,  
City of mailing Address:: Tokyo  
Country of mailing address:: Japan